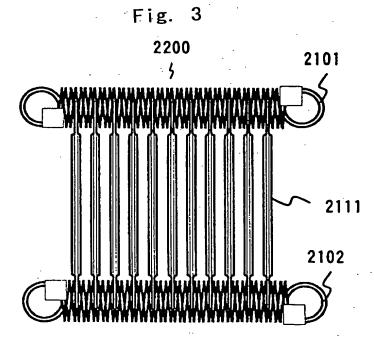
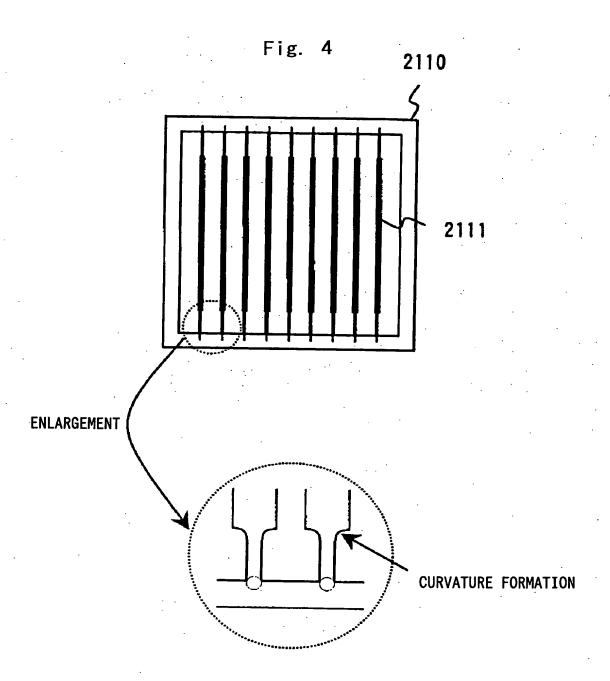


2100 2101 5 2111

CLOCKWISE TWINING SPRING - CLOCKWISE TWINING SPRING



CLOCKWISE TWINING SPRING - UNCLOCKWISE TWINING SPRING



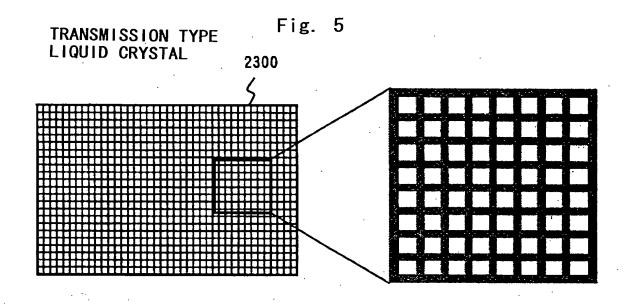


Fig. 6

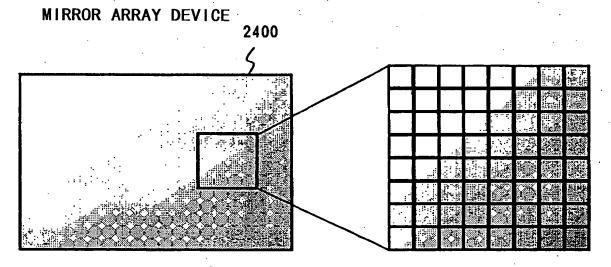
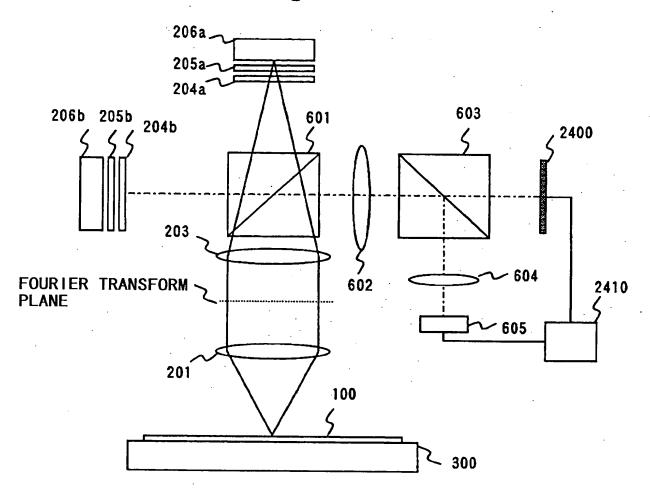


Fig. 7

	TRANSMISSION TYPE	MIRROR ARRAY DEVICE	
OPENING RATE	× LOW OPENING RATE POLARIZATION NECESSITY	O HIGH OPENING O RATE O POLARIZATION NEEDLESSNESS	
TRANSMISSION RATE			
COMPOSITION OF OPTICAL SYSTEM	○ TRANSMISSION	X REFLECTION OPTICAL SYSTEM NECESSITY	

Fig. 8



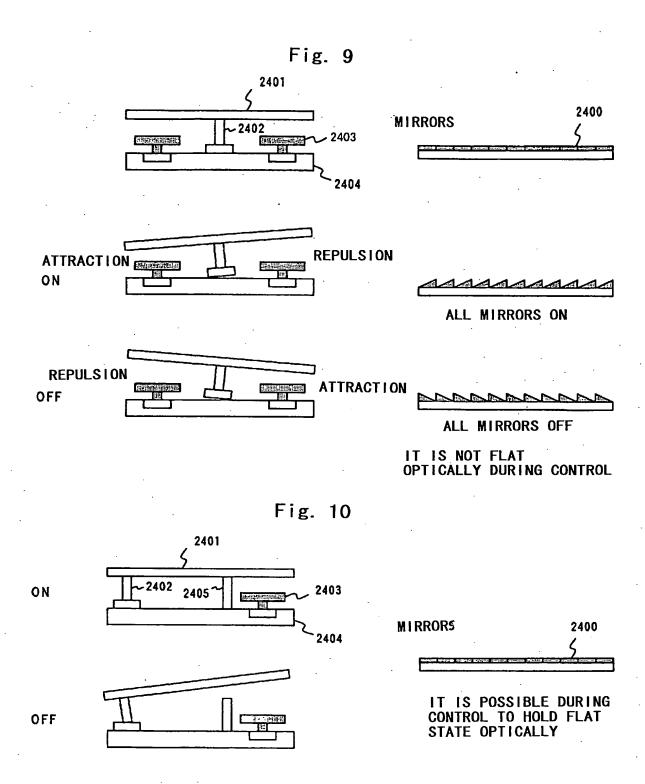


Fig. 11

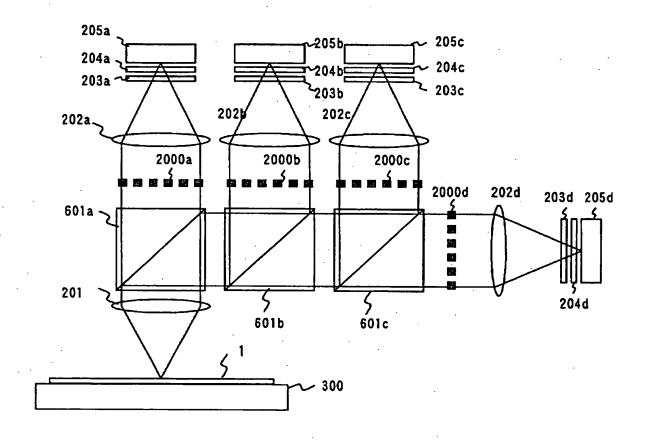


Fig. 12

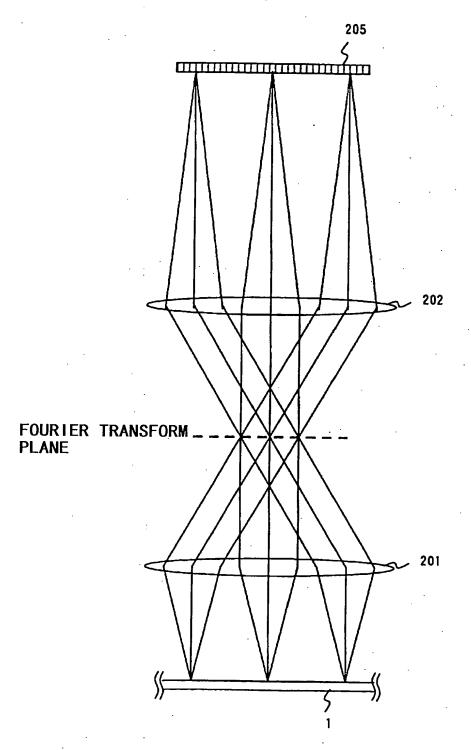


Fig. 13

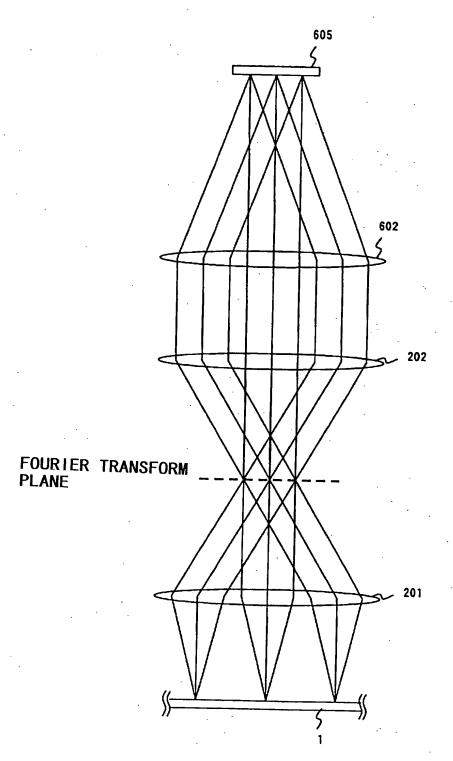
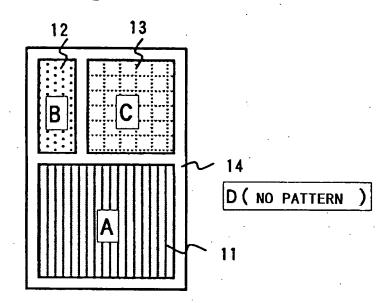


Fig. 14



CHIP LAYOUT

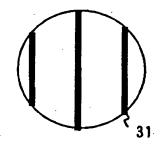
Fig. 15

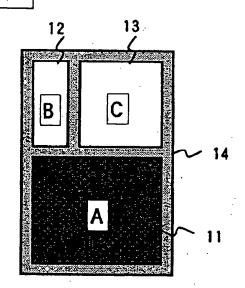
	AREA A	AREA B	AREA C	AREA D
DIFRACTION PATTERN	21	222	23	24
OPTIMAL SHIELDING PATTERN	31	32	+ + + + + + + + + + + + + + + + + + + +	34

Fig. 16

INSPECTION METHOD 1

SPATIAL FILTER PATTERN





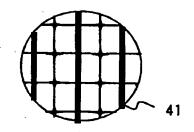
SENNSIVITY

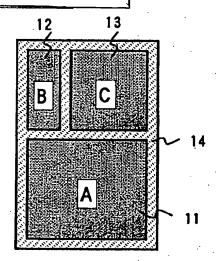
LOW HIGH

Fig. 17

INSPECTION METHOD 2 (SPATIAL FILTER CORRESPONDING WITH ALL AREAS)

SPATIAL FILTER PATTERN





SENNSIVITY

LOW

HIGH

Fig. 18

INSPECTION METHOD 3 (SPATIAL FILTER ACCORDING TO EACH AREA)

SPATIAL FILTER PATTERN AFTER INSPECTION RESULT MERGE SENNSIVITY LOW

Fig. 19

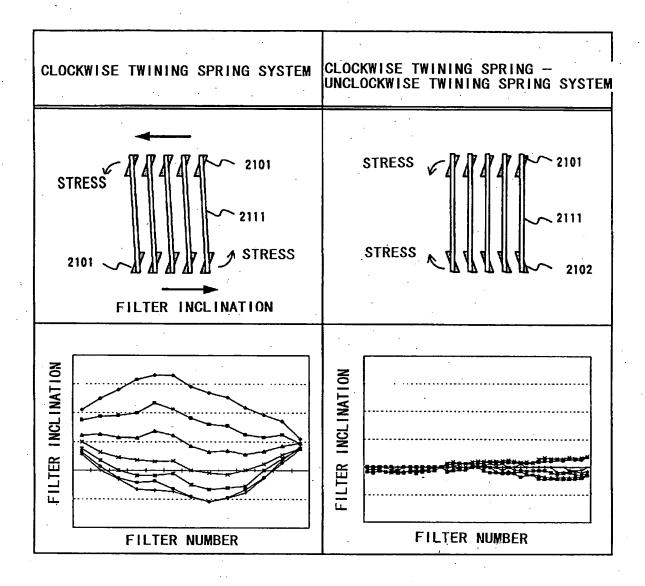


Fig. 20

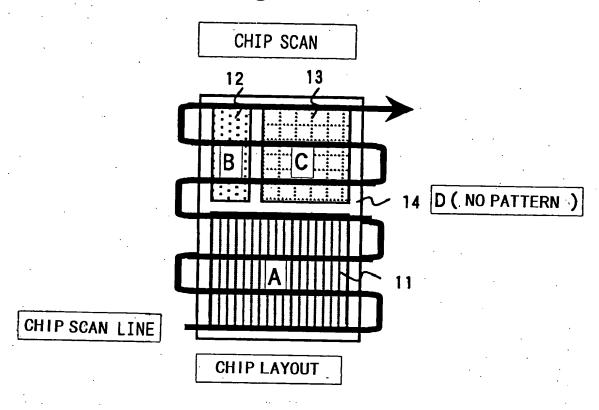


Fig. 21

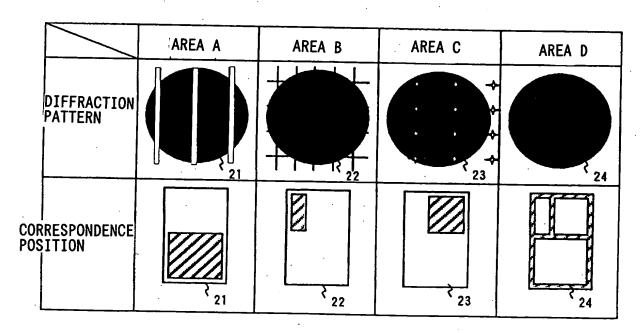


Fig. 22

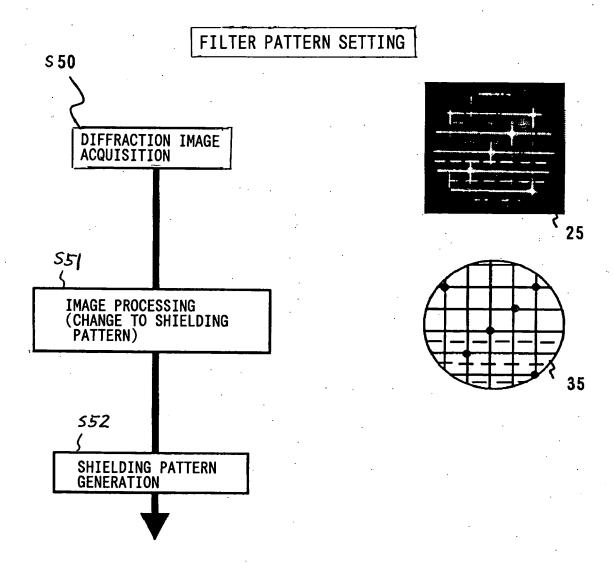
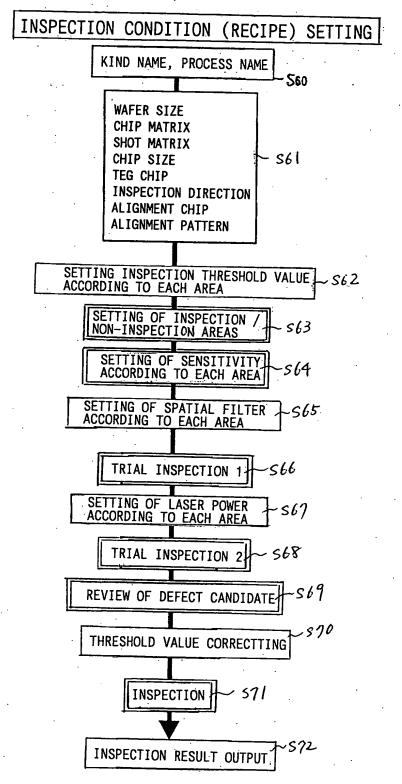
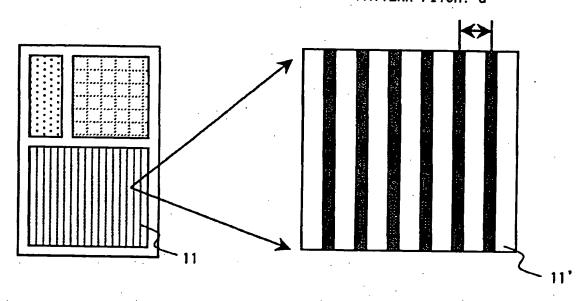


Fig. 23



PATTERN PITCH: d



DIFFRACTION PITCH (P) BEING CALCULATED FROM PATTERN PITCH (d)
$$p = \frac{f \cdot \lambda}{d}$$

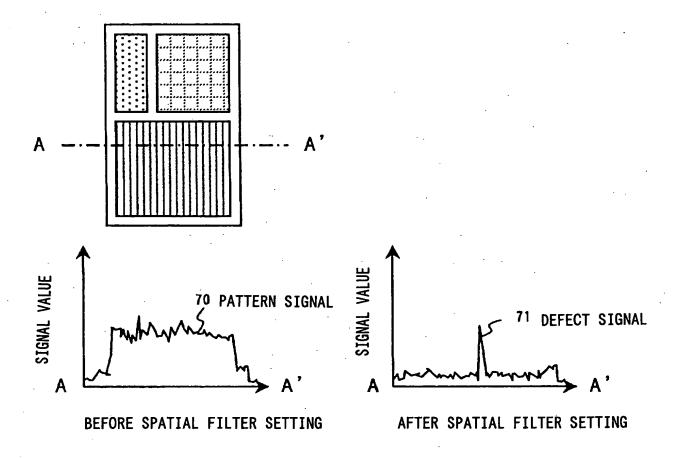


Fig. 26

